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	Application No.	Applicant(s)	/ CM
	10/814,169	INOUE, SATOSHI	
Notice of Allowability	Examiner	Art Unit	
	David Nhu	2818	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	6 (OR REMAINS) CLOSED in this ap ) or other appropriate communicatio RIGHTS. This application is subject t	oplication. If not included n will be mailed in due cou	ırse. THIS
1. X This communication is responsive to 2/15/05.			
2. The allowed claim(s) is/are <u>1-17</u> .			
3. $\boxtimes$ The drawings filed on <u>01 April 2004</u> are accepted by the E	xaminer.		
<ul> <li>4.  Acknowledgment is made of a claim for foreign priority u <ul> <li>a)  All b)  Some* c)  None of the:</li> <li>1.  Certified copies of the priority documents hav</li> <li>2.  Certified copies of the priority documents hav</li> <li>3.  Copies of the certified copies of the priority do International Bureau (PCT Rule 17.2(a)).</li> </ul> </li> <li>* Certified copies not received:</li> </ul>	e been received. e been received in Application No		ı from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file a reply MENT of this application.	complying with the requir	ements
5. A SUBSTITUTE OATH OR DECLARATION must be subminformal PATENT APPLICATION (PTO-152) which give	nitted. Note the attached EXAMINEF ves reason(s) why the oath or declar	R'S AMENDMENT or NOT ation is deficient.	ICE OF
6. CORRECTED DRAWINGS (as "replacement sheets") mu	st be submitted.		
(a) I including changes required by the Notice of Draftsper	son's Patent Drawing Review ( PTO	-948) attached	
1)  hereto or 2)  to Paper No./Mail Date	<b>_·</b>		
(b) including changes required by the attached Examiner Paper No./Mail Date	's Amendment /.Comment or in the	Office action of	
Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in	1.84(c)) should be written on the draw the header according to 37 CFR 1.121	ings in the front (not the ba (d).	ck) of
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT	osit of BIOLOGICAL MATERIAL FOR THE DEPOSIT OF BIOLOGIC	must be submitted. Note	e the
<ul> <li>Attachment(s)</li> <li>1.  Notice of References Cited (PTO-892)</li> <li>2.  Notice of Draftperson's Patent Drawing Review (PTO-948)</li> <li>3.  Information Disclosure Statements (PTO-1449 or PTO/SB/Paper No./Mail Date</li> <li>4.  Examiner's Comment Regarding Requirement for Deposit of Biological Material</li> </ul>	6. ☐ Interview Summary Paper No./Mail Da 708), 7. ☐ Examiner's Amend 8. ☑ Examiner's Statem 9. ☐ Other	ate .	·

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## **REASONS FOR ALLOWANCE**

1. Claims 1-17 are allowed.

2. The following is an examiner's statement of reasons for allowance: None of the references of record teaches or suggests as cited in claim 1: melting and crystallizing the semiconductor film by a heat treatment to form a crystalline semiconductor film including substantially single crystalline grains substantially centered on the respective fine hole; forming a semiconductor elements by using the crystalline semiconductor film; causing peeling at an inside and /or a boundary surface of the peeling layer to separate the semiconductor element from the first substrate and transferring the semiconductor element to a second substrate.

3. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

## CONCLUSION

4. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure: Nishikawa et al (6,523,236 B1): Manufacturing Method for an Ink Jet Recording Head.

5. Any inquiry concerning this communication on earlier communications from the examiner should be directed to David Nhu, (703) 306-5796. The examiner can normally be reached on Monday-Friday from 7:30 AM to 5:00 PM.

The examiner's supervisor, David Nelms can be reached on (703) 308-4910.

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The fax phone number for the organization where this application or proceeding is assigned is (703) 308-872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956

David Nhu

FN)

March 14, 2005

DAVID NAU PRIMARY EXAMINER